

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

O I P E
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 P A T E N T & T R A D E M A R K S
 Applicant : Shimizu, et al.
 Appl. No. : 10/618,900
 Filed : July 14, 2003
 For : SINGLE-WAFER-PROCESSING
 TYPE CVD APPARATUS
 Examiner : Rudy Zervigon
 Group Art Unit : 1763

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

August 5, 2005

(Date)



 Katsuhiro Arai, Reg. No. 43,315
 AMENDMENT

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed May 5, 2005, please reconsider the present application in light of the following amendments and comments.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendments to the Drawings begin on page 5 of this paper. A "Replacement Sheet" for each sheet of drawings being amended can be found in the Appendix.

Remarks/Arguments begin on page 6 of this paper.